

Electronic Acknowledgement Receipt

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Application Number:	10748076
Confirmation Number:	6886
Title of Invention:	Method and system for immersion lithography
First Named Inventor:	Chia-Hui Lin
Customer Number:	54657
Filer:	Steven E. Koffs/Wanda Staples
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File Listing:

Document Number	Document Description	File Name	File Size(Bytes)	Multi Part	Pages
1	Response to Election / Restriction Filed	TSMC20030813ResponseRestrictionRequirement.pdf	102420	no	2

Warnings:**Information:****Total Files Size (in bytes):**

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If a new application is being filed and the application includes the necessary components for a filing date (see 37 CFR 1.53(b)-(d) and MPEP 506), a Filing Receipt (37 CFR 1.54) will be issued in due course and the date shown on this Acknowledgement Receipt will establish the filing date of the application.

National Stage of an International Application under 35 U.S.C. 371

If a timely submission to enter the national stage of an international application is compliant with the conditions of 35 U.S.C. 371 and other applicable requirements a Form PCT/DO/EO/903 indicating acceptance of the application as a national stage submission under 35 U.S.C. 371 will be issued in addition to the Filing Receipt, in due course.